

Principles of Electronic Nanobiosensors

Unit 3: Sensitivity

Lecture 3.11: Cantilever-based Sensors:
Static Response

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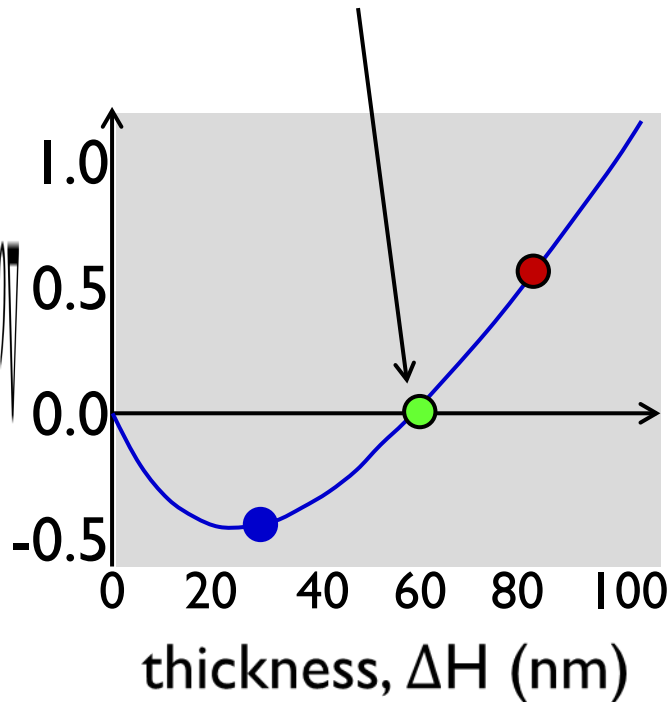


Outline

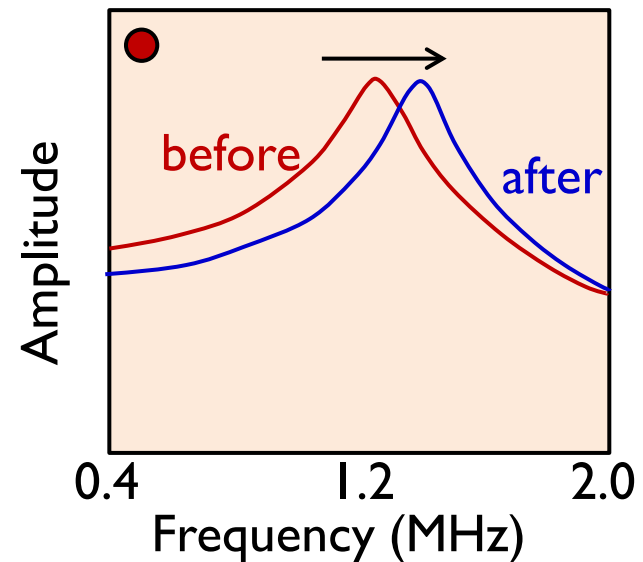
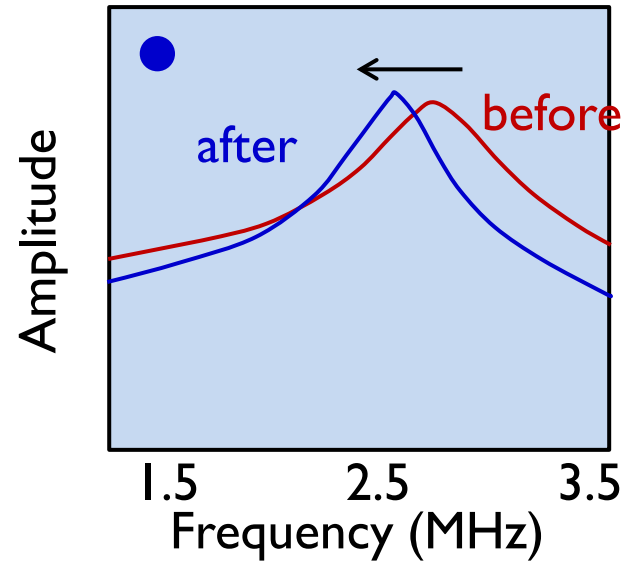
- **Review : dynamic biosensing**
- **Static biosensing**
 - Challenges of mass-based sensing
 - Nonlinear biosensing with electrostatic actuation
- **Conclusion**

Reversal of frequency at nanoscale

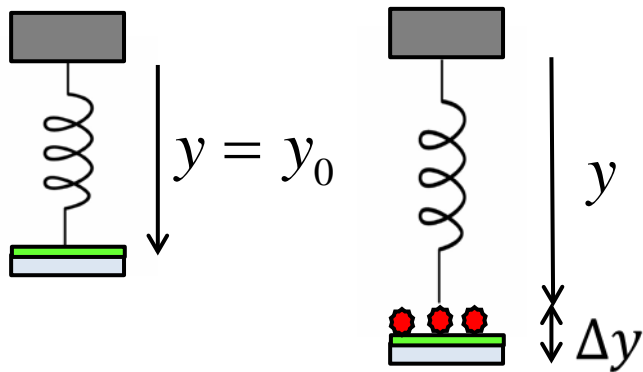
$$\frac{dH_c}{H} = \sqrt{\frac{E_b \rho_a}{E_a \rho_b} - 1}$$



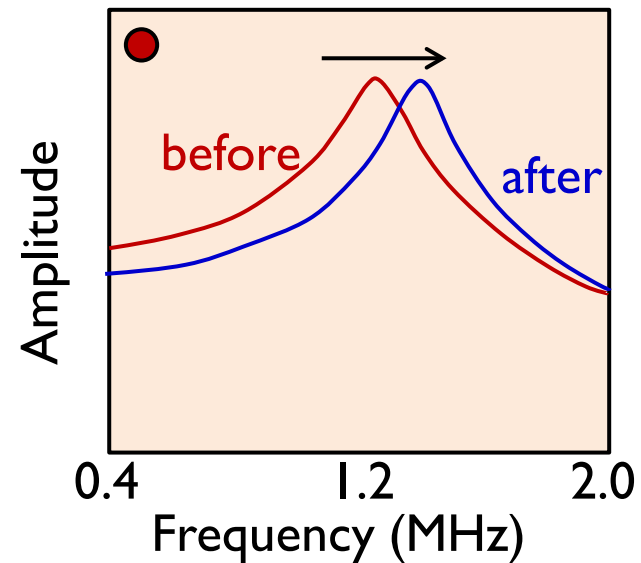
balance between
mass and spring effects



Broadening of frequency response



$$f = \frac{\omega}{2\pi} = \frac{1}{2\pi} \sqrt{\frac{k}{m}}$$

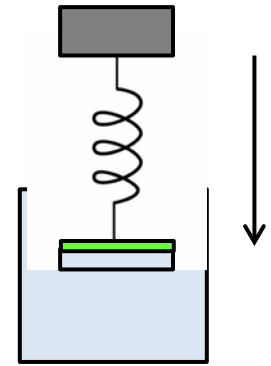


Response is broaden, and the peak is displaced.

Frequency change due to damping (in water) in response to Transient Input

$$m \frac{d^2 y}{dt^2} + \gamma \frac{dy}{dt} + ky = F_{ext} = 0$$

Solution:



$$y = Ae^{-\alpha\omega_0 t} \sin(\omega' t + \phi)$$

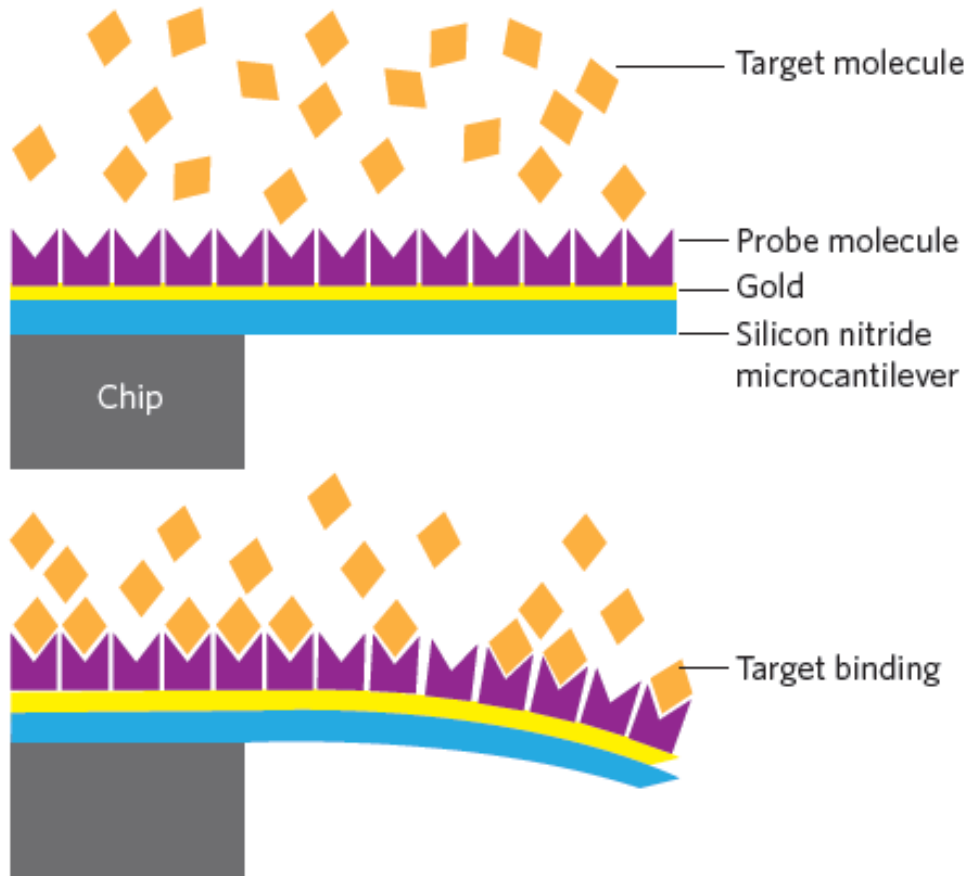
$$\alpha = \frac{\gamma}{2m\omega_0} \equiv \frac{1}{2Q} \quad \omega' = \left(\frac{k}{m} - \frac{\gamma^2}{4m^2} \right)^{\frac{1}{2}}$$

The response is damped and the natural frequency changed.

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Static deflection can be measured



Mass increase
Surface stress
Spring constant

Static detection: At your supermarket

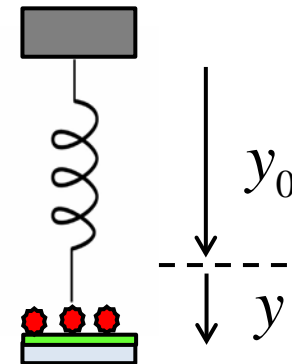
$$m \frac{d^2 y}{dt^2} + \gamma \frac{dy}{dt} + ky = F = mg$$

$$k \equiv \alpha_2 \frac{EI}{L^3}$$

$$ky = F = mg$$

$$\frac{\Delta k}{k_0} + \frac{\Delta y}{y_0} = \frac{\Delta m}{m_0}$$

$$\frac{\Delta y}{y_0} = \frac{\Delta m}{m_0} - \frac{\Delta k}{k_0}$$



the mass change vs. the change in stiffness ...

An Example: Mass-induced deflection

Si beam: $L=5 \text{ }\mu\text{m}$, $W=1.5\mu\text{m}$ $H=25\text{nm}$, Density= 2330 Kg/m^3

Protein: $L=5 \text{ }\mu\text{m}$, $W=1.5\mu\text{m}$ $H=50\text{nm}$, Density= 1220 Kg/m^3

$$\frac{\Delta y}{y_b} = \frac{\Delta m}{m_b} = \frac{\rho_T \Delta H W L}{\rho_b H W L} = \frac{1220 \times 50}{2330 \times 25} \sim 1 \quad \text{Great sensitivity}$$

$$y = \frac{m}{k} g = \frac{6.3 \times 10^{-17} \text{ Kg}}{0.0152 \text{ N/m}} \times 9.8 \frac{\text{m}}{\text{s}^2} = 40.6 \text{ fm} \quad \text{Unmeasurable!}$$

If we could somehow soften the spring!

Static vs. dynamic response

$$y = A \cos(\omega t)$$

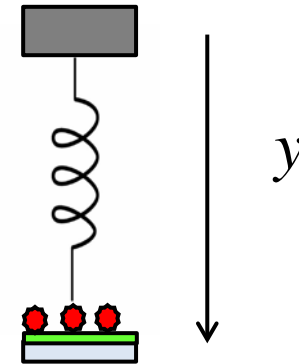
$$a \equiv \frac{d^2 y}{dx^2} = \omega^2 A$$

$$a = \omega^2 A$$

$$= (2\pi \times 2.4 \times 10^6)^2 \times 10^{-9} \text{ m}$$

$$= 2.27 \times 10^5 \text{ m} \cdot \text{s}^{-2}$$

$$\sim 23,000 g$$

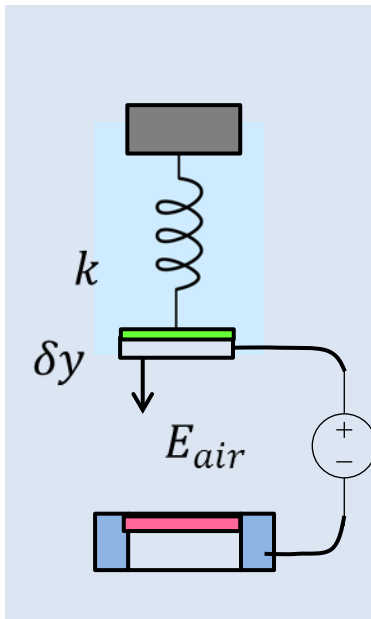


High acceleration allowed measurement of small mass
(essence of centrifuge operation)

Displacement with an static force

Force balance equation

$$m \frac{d^2 y}{dt^2} + \gamma \frac{dy}{dt} + k(y_0 - y) = F_{ext} + F_{elec}$$



At Steady state: $k(y_0 - y) = F_{ext} + F_{elec}$

Electrical force: $E = \frac{1}{2} CV^2$

$$F_{elec} = \frac{dE}{dy} = -\frac{1}{2} V^2 \frac{dC}{dy}$$

$$C = \frac{\epsilon_0 A}{y}$$

$$k \equiv \frac{\alpha_2 EI}{L^3}$$

$$C = \frac{\epsilon A}{y}$$

Spring-softening

Equilibrium condition:

$$k(y_0 - y) = -\frac{d}{dy} \left(\frac{CV^2}{2} \right) = \frac{V^2 \epsilon A}{2y^2}$$

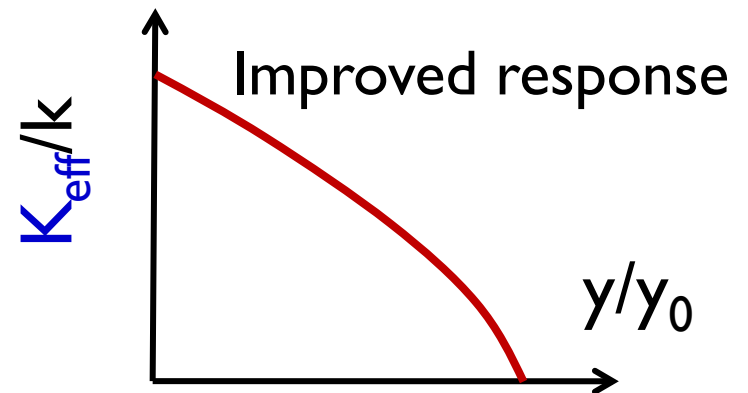
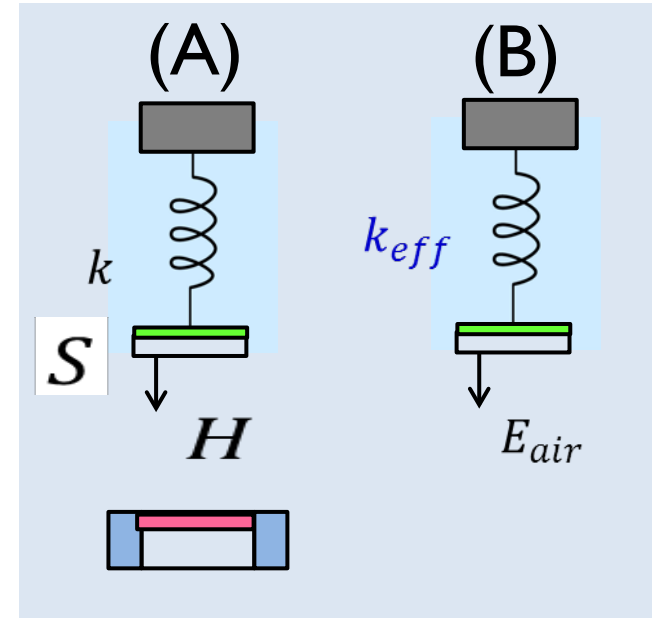
As if the spring has weakened ..

$$F_{ext} \equiv k(y_0 - y) + \frac{d}{dy} \left(\frac{CV^2}{2} \right)$$

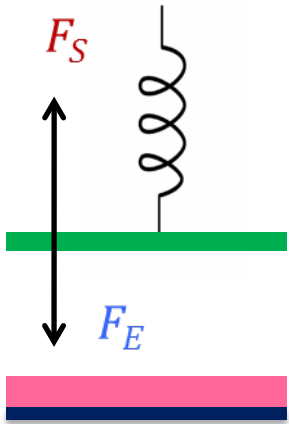
Effective spring constant:

$$k_{eff} = -\frac{dF_{ext}}{dy} = k - \frac{2V^2 \epsilon A}{2y^3}$$

$$k_{eff} = k - \frac{2}{y} k (y_0 - y) = k \left(3 - \frac{2y_0}{y} \right)$$



Pull-in instability



$$E = \frac{1}{2} CV^2$$

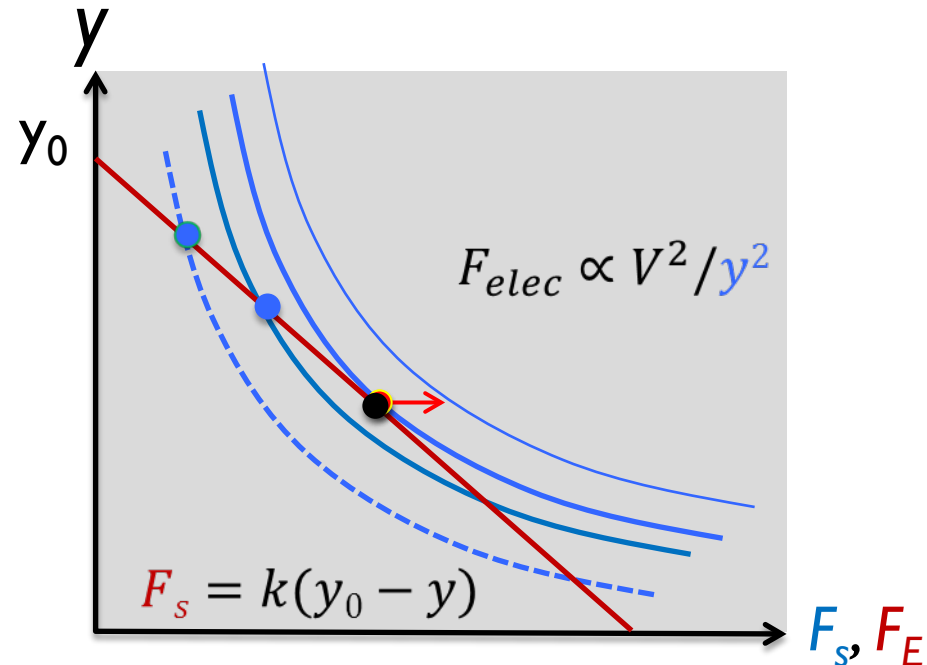
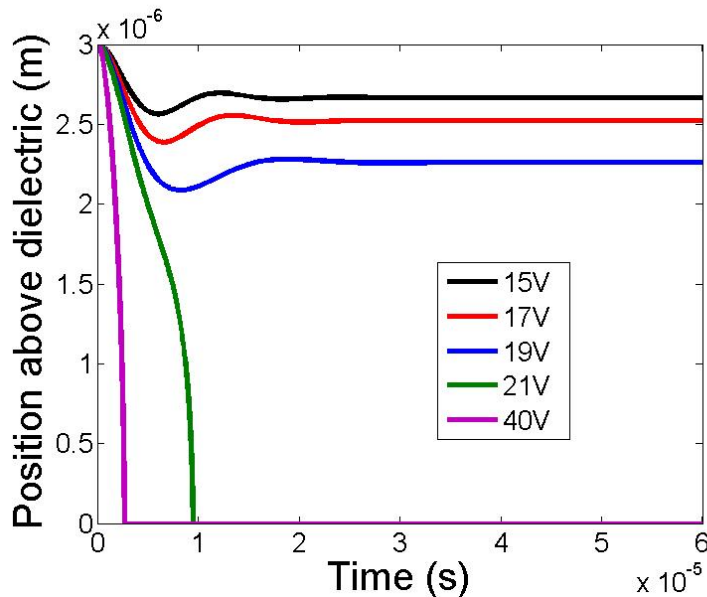
$$F_{elec} = \frac{dE}{dy} = -\frac{1}{2} V^2 \frac{dC}{dy}$$

$$C = \frac{\epsilon_0 A}{y}$$

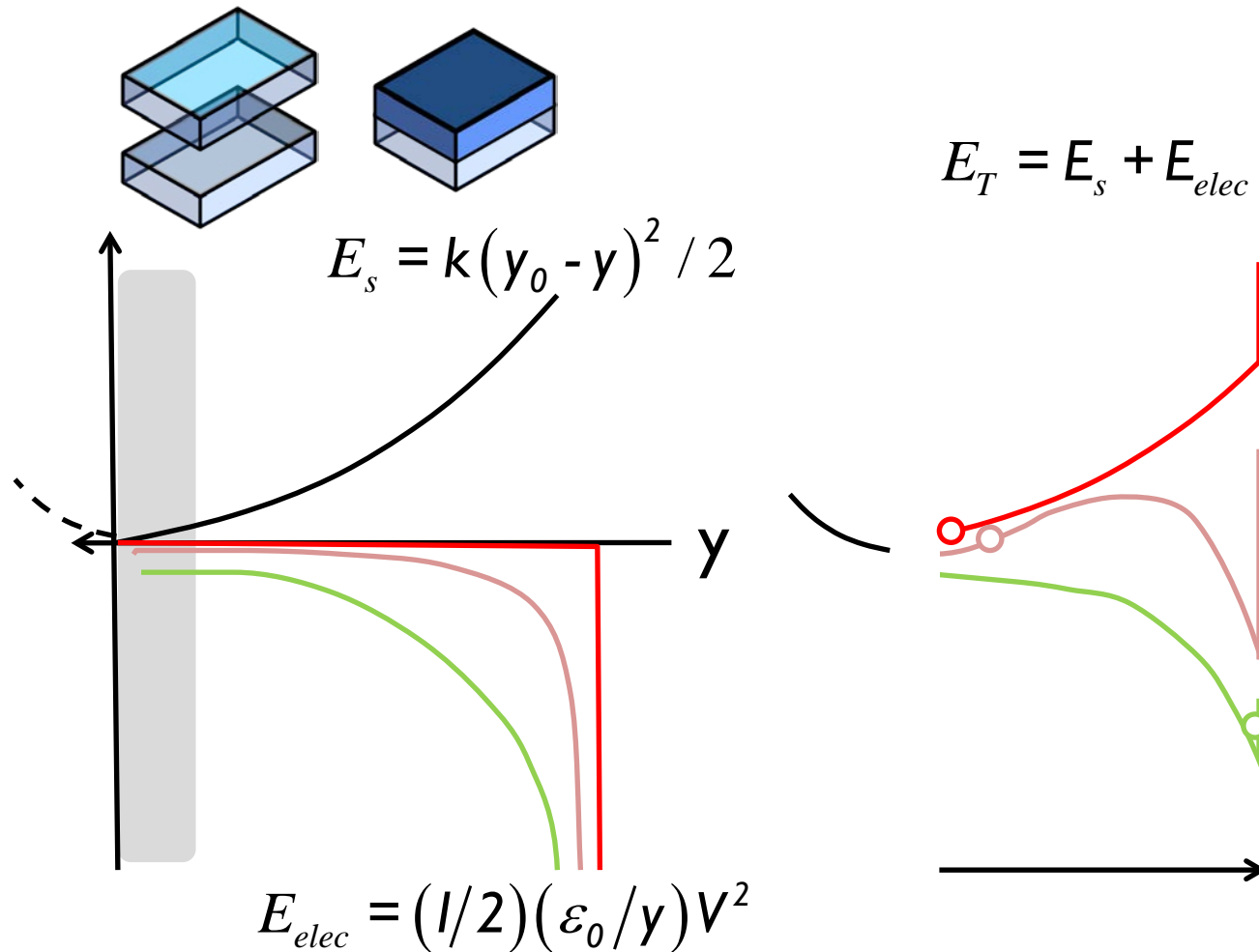
$$F_{elec} = F_s$$

$$\frac{dF_{elec}}{dy} = \frac{dF_s}{dy}$$

$$y^* = \frac{2}{3} y_0$$



Energy Landscape of Spring weakening



Effective spring constant changes due to changes in energy landscape

Conclusions

- Dynamic biosensing is widely used. Frequency reversal and fluid damping at the nanoscale make things complicated.
- Pure mass-based static deflection is difficult to measure.
- Spring-softening can be achieved by changes in material properties and cantilever geometry, but electrostatic actuation provides a simpler approach.

References

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Homework: Resonance in CNT

- I The following example is taken from Zhong et al. NL, 2010. A CNT is suspended over a ridge defined by two SiO₂ pillars. Assume the following parameters for CNT: $d=2\text{nm}$, $L=3\text{ micron}$, $E=1\text{ TPa}$, mass density, $\mu=5\times 10^{-15}\text{ (kg/m)}$, moment of inertia (I) = 7×10^{-37} , $\epsilon=8.854\times 10^{-12}$, and height $y_0=1\text{ um}$.
- (a) Find the effective spring constant, k , for the system. Show that the resonant frequency is given by $\sim 11\text{ MHz}$.
 - (b) If k changes by 10% due to biomolecule absorption, find the corresponding change in frequency.
 - (c) Derive an expression for spring hardening to show $f=f_0 + A V_{\text{gate}}^2$, where $A \sim C \sqrt{I / \mu E I}$. Recall that $C = 2\pi \epsilon_0 L / \ln(2 y_0 / d)$.